

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	<b>MAIL STOP AFTER FINAL</b>
Jung-hyun Lee et al.	)	Group Art Unit: 2811
Application No.: 10/797,046	)	Examiner: Ori NADAV
Filed: March 11, 2004	)	Confirmation No.: 4688
For: METHOD FOR MANUFACTURING	)	
OXIDE FILM HAVING HIGH	)	
DIELECTRIC CONSTANT,	)	
CAPACITOR HAVING DIELECTRIC	)	
FILM FORMED USING THE	)	
METHOD, AND METHOD FOR	)	
MANUFACTURING THE SAME	)	

**RESPONSE UNDER 37 C.F.R. § 1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated October 22, 2008, Applicants submit herewith a petition for one month extension of time extending the period for response from January 22, 2009 to February 22, 2009 and the following Amendments and Remarks.

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this Response.

**Remarks** begin on page 3 of this Response.

DO NOT ENTER: /O.N./